



5 2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
PATENT APPLICATION

Application of:

Xiaoju Wu

Docket: **TI-33227**

Serial No.: **10/013,088**

Art Unit: **2814**

Filed: **12/07/2001**

Examiner: **A. Mai**

For: **METHOD OF MANUFACTURING AND STRUCTURE OF
SEMICONDUCTOR DEVICE WITH FIELD OXIDE STRUCTURE**

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING 37 CFR 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on the date indicated below.

8-28-03

Jackie McBride
Jackie McBride

10-2000 MAIL ROOM

EXTENSION OF TIME

Sir:

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner for an extension of the shortened statutory period in the above-referenced application.

The fee for this extension is indicated below:

X One Month (\$110)

Please charge the fee to Deposit Account No. 20-0668. Any further necessary extension of time is hereby requested. Charge any additional fee or credit any overpayment to Deposit Account No. 20-0668. This paper is submitted in duplicate.

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Respectfully submitted,

Yingsheng Tung
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